

Electronic Patent Application Fee Transmittal

Application Number:	10599861			
Filing Date:				
Title of Invention:	LOADING DEVICE FOR CHEMICAL MECHANICAL POLISHER OF SEMICONDUCTOR WAFER			
First Named Inventor/Applicant Name:	Jung Hoon LEE			
Filer:	Jeffrey A. Wyand/Malika Ash Shakur			
Attorney Docket Number:	403835			
Filed as Small Entity				
U.S. National Stage under 35 USC 371 Filing Fees				
Description	Fee Code	Quantity	Amount	Sub-Total in USD(\$)
Basic Filing:				
Natl Stage Search Fee - Report provided	2642	1	200	200
Natl Stage Exam Fee - all other cases	2633	1	100	100
Pages:				
Claims:				
Miscellaneous-Filing:				
Oath/decl > 30 mo. from priority date	2617	1	65	65
Petition:				
Patent-Appeals-and-Interference:				

Description	Fee Code	Quantity	Amount	Sub-Total in USD(\$)
Post-Allowance-and-Post-Issuance:				
Extension-of-Time:				
Miscellaneous:				
Total in USD (\$)				365